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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 2812

Application No.: 10/722,422

Examiner: J. KENNEDY

Filed: November 28, 2003

Docket No.: 117897

For: METHOD OF MANUFACTURING CERAMIC FILM, METHOD OF
MANUFACTURING FERROELECTRIC CAPACITOR, CERAMIC FILM,
FERROELECTRIC CAPACITOR, AND SEMICONDUCTOR DEVICE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the August 23, 2005 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.